

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:	) Confirmation No.: 9428
Shunpei <b>YAMAZAKI</b> , et al.	)
Serial No. 10/678,139	) Examiner: Mary A. Wilczewski
Filed: October 6, 2003	) Group Art Unit: 2822
For: METHOD FOR FABRICATING SEMICONDUCTOR THIN FILM	)

**AMENDMENT**

United States Patent and Trademark Office  
Customer Service Window, **Mail Stop Amendment**  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir:

In response to the Office Action dated April 4, 2011, please consider Applicants' remarks as follows.

**A Listing of the Claims** begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.